

<b>Notice of References Cited</b>	Application/Control No. 09/819,492	Applicant(s)/Patent Under Reexamination LIU ET AL.	
	Examiner Clemence Han	Art Unit 2665	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,101,189	08-2000	Tsuruoka, Tetsumei	370/401
	B	US-6,157,950	12-2000	Krishnan, Kalyan	709/223
	C	US-6,353,614	03-2002	Borella et al.	370/389
	D	US-6,480,508	11-2002	Mwikalo et al.	370/475
	E	US-6,563,824	05-2003	Bhatia et al.	370/392
	F	US-6,779,039	08-2004	Bommareddy et al.	709/238
	G	US-6,822,943	11-2004	Mantin, Sharon	370/254
	H	US-6,822,957	11-2004	Schuster et al.	370/389
	I	US-2002/0038339	03-2002	Xu, Wei	709/203
	J	US-2002/0101859	08-2002	Macleam, Ian B.	370/352
	K	US-2002/0116532	08-2002	Berg, Mitchell T.	709/246
	L	US-2003/0165136	09-2003	Cornelius et al.	370/356
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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